HASO SWIR LIFT 160

Wavefront sensor **The Prodigy**

Ultra-high resolution SWIR range Alignment-free







光貿易株式会社 〒113-0034 東京都文京区湯島3-13-8湯島不二ビル301 メール: contact@hikari-trading.com ウェブサイト: http://www.hikari-trading.com hikari ,inc. TEL: 03-3832-3117 FAX: 03-3832-3118



HASO SWIR LIFT 160 +

A great choice for the most demanding SWIR optical metrology applications, the HASO SWIR LIFT 160 wavefront sensor provides the highest resolution in SWIR.

This generation features the new SpotTracker[™] technology. It provides absolute wavefront and tilt information, eliminating alignment requirements for faster and easier implementation.



Compatible with the Optical Engineer Companion modular system: easily combine the accessories you need.

APPLICATIONS

Successfully used in the most demanding applications in optical metrology, microscopy, and laser diagnostics, the HASO SWIR LIFT 160 performs multiple functions :

- + Optical manufacturing metrology
- + Complex optics characterization
- + Middle frequencies mirror surface characterization
- + Optical quality control, metrology (LIDAR, free space
- communication, Automotive, Space and defense)
- + Predict the performance of optical systems in terms of focusing capability or imaging quality
- + Drive a wavefront corrector to correct for system aberrations

+ Quantify the effects of temperature and gravity on system performance

FEATURES

+ Direct wavefront acquisition of highly converging and diverging beams with an accuracy of λ /100 RMS, including astigmatism and highorder aberrations, and many other parameters, making it the perfect instrument for any complex optics alignment

- + Beam collimation with sensitivity > 1 km radius of curvature
- + Control and adjustment of axial laser beam deviation > 3 µrad RMS
- + Complex optics characterization in single or double path configuration in combination with R-FLEX2 metrology systems or R-FLEX LA metrology platforms
- + 3D MTF measurements



SPECIFICATIONS*

OPERATING SPECS

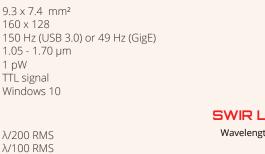
Aperture dimension Phase sampling Maximum acquisition frequency Calibrated wavelength range Minimum power External trigger Operating system

OPTICAL SPECS

Repeatability Absolute wavefront measurement accuracy Spatial sampling Tilt dynamic range Focus dynamic range

MISC

Dimension Weight for USB version Working temperature Interface Power consumption



75 x 78 x 63 mm³ (USB 3.0) 250 g 15 - 30 °C USB 3.0 or GigE < 5 W

58 µm

> ± 3°

± 0.040 m to ± ∞



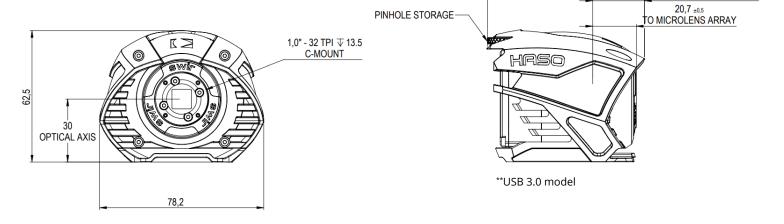


74,6

*Subject to changes without further notice

HASO SWIR LIFT 160 Dynamic range at $\lambda = 1550$ nm

DIMENSIONS (mm)**



24,6 ±0,5 TO MICROLENS ARRAY

SOFTWARE

WAVEVIEW[™] Metrology Software

WAVEVIEW[™] is the most advanced wavefront measurement and analysis software.

It offers more than 150 features and tools optimized for a wide range of highly demanding applications.

Options :

+ Extensions for PSF, MTF and Strehl ratio

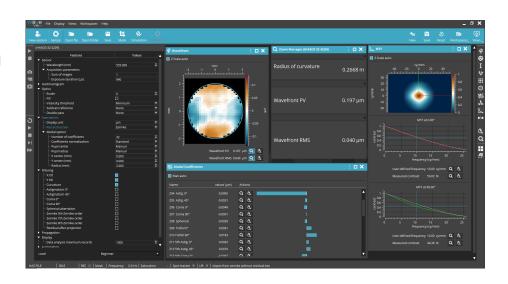
+ Optional SDK in C/C++, LabVIEW and Python

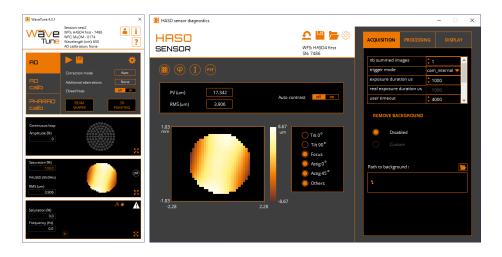
WAVETUNE™ Adaptive Optics Software

WAVETUNE[™] is a unique software that seamlessly combines wavefront measurement and correction features with extensive instrument diagnostics. It is perfectly adapted to our HASO wavefront sensors, ILAO STAR, MIRAO and mu-DM deformable mirrors, as well as to a wide range of active components.

Options:

+ Optional SDK in C/C++, LabVIEW and Python









HASO SWIR LIFT 160 DATASHEET 2311